

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Shinji Omori et al.

Application	10/534,917	Group Art Unit:	2892
Filed:	September 26, 2005	Confirmation No.	1773
Customer No.:	26263	Examiner:	Phuc T. Dang
For:	EXPOSURE DEVICE, EXPOSURE METHOD, AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD		

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT "A"

Sir:

This amendment is filed in response to the non-final Office Action mailed April 8, 2008. Please reconsider the application in view of the amendments and remarks presented herein.